

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**Priority** Application Serial No. .... 10/297,001  
**Priority** Filing Date ..... November 26, 2002  
Inventor..... Jianxing Li et al.  
Assignee..... Honeywell International Inc.  
**Priority** Group Art Unit ..... 2812  
**Priority** Examiner ..... Gurley, Lynne Ann  
Attorney's Docket No. .... 30-5082-DIV1  
Customer No. .... 021567  
Title: Sputter Target Compositions, and Methods of Inhibiting Copper Diffusion into a  
Substrate

**PRELIMINARY AMENDMENT**

To: MS Patent Application  
Commissioner for Patents  
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**AMENDMENTS**

**Introductory Comments**

This Preliminary Amendment accompanies filing of a divisional application.  
Applicant amends the application and remarks as follows.